



Fast, Sensitive, Ultra-low Power Thermal Conductivity Micro Sensor

¹School of Mechanical Engineering, Georgia Institute of Technology, Atlanta, GA 30332 ²KWJ Engineering Inc. Newark, CA 94560

What is Thermal Conductivity **Detector (TCD)**?

A TCD obtains information about composition of surrounding gas medium by thermo-physical analysis of the gas.



polysilicon a suspended doped Resistance of structure is a function of temperature; if heated, its temperature depends on thermal conductivity and thermal capacity of the gas.



Motivations for microTCD

Conventional gas detectors suffer

- large power consumption
- slow time response
- Frequent re-calibration requirement
- Memory effects and frequent replacement

microTCD gas sensors offer

- Much lower power consumption
- Faster time response
- Enhanced sensitivity
- Lower cost

Applications of the present work

- Detection of Helium leaks in space station
- Detection of natural gas leak and detection of methane in mining
- Air quality monitoring.
- Combustion process monitoring and optimization
- Gas chromatography (GC) systems
- Health: breath analysis detection of NO, CO₂, O₂

Alireza Mahdavifar¹, Peter Hesketh¹, Ricardo Aguilar¹, Mel Findlay², Joseph R. Stetter²

Micro-Fabrication Process



- 1. Thermally grown SiO2, 10 μm 2. Silicon Nitride Layer LPCVD, 0.4 μm 3. Polysilicon layer LPCVD, 1µm 4. P-type doping of Polysilicon 5. Silicon Nitride LPCVD, 0.2 μm 6. RIE for electrical contacts 7. Pt and Au evaporations for contacts 8. RIE of nitride to form a mask for SiO2
- etching
- 9. BOE etching of SiO2, beam suspension



Computer Simulation of Sensor Operation



Modeling Results



Free convection over sensor

Temperature gradient in the gas and on the bridge

Simulation features

- Minimal simplifications
- Steady state and transient
- Takes into the accounts Conduction, convection and radiation
- Couples electrical current, heat transfer and fluid mechanics physics







Society 161.4 (2014): B55-B61.